



E UNITED STATES PATENT AND TRADEMARK OFFICE (213.003-D2-US)

In re Application of: Ye et al.

Serial No: 10/763,142

Filed: January 22, 2004

Title: Method and Apparatus for Monitoring

Integrated Circuit Fabrication

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Group Art Unit: 2125

Examiner:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on May 4, ZXV4

person signing this certificate)

Signature

FIRST INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Submitted herewith are ten (10) sheets of a modified Form PTO-1449. All of the documents listed on the modified Form PTO-1449 were provided or cited in the parent application of the above-captioned application. Accordingly, the documents are not enclosed herewith. (See 37 C.F.R. §1.98(d) and MPEP 609). Should the Examiner desire an additional copy of the documents, kindly contact the undersigned.

It is respectfully requested that the Examiner make his/her consideration of these references formally of record with the initial Office Action.

Date: May 4, 2004

Neil A. Steinberg Reg. No. 34,735

Respectfully submitted,

650-968-8079

ATTY. DOCKET NO. 213.003-D2-US SERIAL NUMBER

10/763,142

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

APPLICANT(S)

Ye et al.

FILING DATE

GROUP ART UNIT

January 22, 2004

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